

AFC
09/29/03
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P97-0041US3

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Raymon F. THOMPSON *et al.*

APPLICATION No.: 09/575,551

FILED: MAY 22, 2000

FOR: SEMICONDUCTOR PROCESSING SYSTEM WITH
WAFER CONTAINER DOCKING AND LOADING
STATION

EXAMINER: James W. Keenan

ART UNIT: 3652

**AMENDMENT IN SECOND REQUEST FOR CONTINUING
EXAMINATION
FOLLOWING DECISION ON APPEAL**

A Decision on Appeal from the final rejection of claims 56, 57, 62, 64, and 65 was mailed February 26, 2003. In response to an RCE filed 4/28/03, the appealed claims as amended were allowed, and new claims 66-72 were restricted out. With the filing of this second RCE herewith, applicant cancels the allowed appealed claims and requests prompt examination of the new claims 66-72.

In the Claims:

Please cancel claims 56, 57, 62, 64 and 65.

A Notice of Allowance is requested.

Respectfully submitted,
Perkins Coie LLP

Date: August 19, 2003

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